

Jacob U. Arber

Associate Attorney

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New York

Jacob Arber is a litigation associate in the New York office of Gibson, Dunn & Crutcher and a member of the firm's Privacy, Cybersecurity, and Data Innovation and Labor and Employment practice groups. Jacob represents a range of clients in all stages of complex litigation from motions to dismiss to trial and appeal. He has particular experience drafting winning motions in court and persuasive submissions to regulators. Jacob also regularly advises clients on privacy and tech-related risks, including compliance with the California Consumer Privacy Act, Illinois Biometric Information Privacy Act, and other federal and state laws and regulations.

Representative privacy, artificial intelligence, and technology matters include:

- Securing a favorable settlement on behalf of a gig economy company in an investigation by a State Attorney General related to compliance with a comprehensive privacy law.
- Representing a gaming company in an investigation by a State Attorney General related to compliance with a state privacy law, which resulted in no action taken by the State Attorney General.
- Representing a major e-commerce platform in litigation against a State Attorney General related to its privacy and commercial practices.
- Representing a major technology company in inquiries by multiple State Attorneys General, which resulted in no action.
- Counseling a major venture capital firm on proposed legislation related to artificial intelligence.
- Advising a range of companies on compliance with state privacy laws, including privacy policies, biometrics, and product development.
- Securing dismissal with prejudice on behalf of a major social networking company of data privacy claims and defending that dismissal on appeal.

Representative labor and employment matters include:

- Securing a sweeping preliminary injunction in a trade-secret and non-compete lawsuit against a former executive.
- Defeating a motion to add an executive and senior employee as individual defendants in a discrimination, retaliation, and harassment suit.
- Representing a major company in arbitrations and administrative proceedings related to the classification of workers as independent contractors.
- Securing a favorable settlement on behalf of a major utility related to wage-and-hour claims.



Capabilities

Litigation
Appellate and Constitutional Law
Artificial Intelligence
Class Actions
Consumer Protection
Labor and Employment
Privacy, Cybersecurity, and Data Innovation
Tech and Innovation
Technology Litigation

Credentials

Education

Columbia University - 2017 Juris Doctor
Georgetown University - 2014 Bachelor of Science

Admissions

New York Bar
California Bar

Clerkships

US Court of Appeals, 2nd Circuit, Hon. Debra Ann Livingston, 2019 - 2020
USDC, Eastern District of New York, Hon. Edward Korman, 2018 - 2019

Jacob also maintains an active *pro bono* practice. He has briefed and argued multiple appeals in the California and New York state appellate courts on behalf of victims of domestic violence and criminal defendants. He also represents an inmate alleging violations of his due process rights.

Jacob clerked for the Honorable Debra Ann Livingston of the United States Court of Appeals for the Second Circuit and for the Honorable Edward R. Korman of the United States District Court for the Eastern District of New York. He earned his Juris Doctor in 2017 from Columbia Law School, where he was a James Kent Scholar and Ruth Bader Ginsburg Prize recipient. Jacob also served as the Executive Submissions Editor for the *Columbia Science and Technology Law Review*. He graduated *magna cum laude* from Georgetown University's School of Foreign Service with a Bachelor of Science in Science, Technology, and International Affairs.

He is admitted to practice in the States of California and New York and in the Northern District of California and Southern District of New York.

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